



Docket No.: 204552031400
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Nobuhiro OHKUBO et al.

Application No.: 10/786,479

Confirmation No.: 3112

Filed: February 26, 2004

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE AND
MANUFACTURING METHOD THEREOF

Examiner: Tod T. Van Roy

AMENDMENT UNDER 37 CFR 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated March 24, 2006, please amend this application as follows.

Amendments to the Drawings begin on page 2 and include an attached replacement sheet.

Remarks/Arguments begin on page 3.

An **Appendix** including amended drawing figures is attached following page 6.